

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(substitute form 1449A)

Application Number: 09/810,825

Filing Date: March 16, 2001

First Named Inventor: MAO et al.

Group Art Unit: unassigned

Sheet 1 of 1

Examiner Name: unassigned

U.S. Patent Documents

Examine r Initials	Cite No.	Document No.	Name of Applicant	Date	Class	Sub- class	Filing Date (if appropriate)
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hy	19	DE	3644802		Schmitt	07/14/88	no
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[Signature]

10/30/02



(substitute form 1449A)

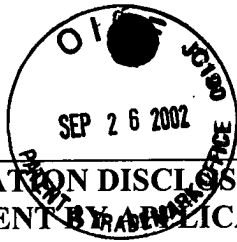
Examiner Name: unassigned

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EXAMINER			DATE CONSIDERED		
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (substitute form 1449A)	Application Number: 09/810,825
	Filing Date: March 16, 2001
	First Named Inventor: Mao
	Group Art Unit: 2834
Sheet 1 of 1	Examiner Name: Tamai, K.

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Examiner Initials	Cite No.	Document No.	Name of Applicant	Date	Class	Sub- class	Filing Date (if appropriate)
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EXAMINER	K. Tamai		DATE CONSIDERED 10/28/12